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(PTO-1449)

ATTY. DOCKET NO.
K-0103C (2016-619)

APPLN. SERIAL NO.
10/607,549

APPLICANT(S)

Jae Cheol LYU et al.

FILING DATE
June 27, 2003

GROUP 1746

U.S. PATENT DOCUMENTS

[illegible]


U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	
1						

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	1134995**	11/06/1996	CHINA (Chinese Abstract and US equivalent 5,657,650)			X	
	08-024475	01/30/1996	JAPAN (English Abstract and Japanese Full Text)			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

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EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
<i>[Signature]</i>	1,234,498	07/1917	SEYMOUR			
	1,496,644	06/1924	KARASINSKI			
	1,850,138	03/1932	RIALL			
	1,971,979	08/1934	HITCHCOCK			
	2,119,918	06/1938	KIRBY			
	2,261,932	11/1941	BUKOLT			
	2,556,153	06/1951	COLLINS			
	2,584,833	02/1952	BEUCLER			
	2,630,001	03/1953	CRINER			
	2,656,702	10/1953	CHAPIN			
	2,700,473	01/1955	EMMERT et al.			
	2,930,216	03/1960	CAZZANIGA			
	5,457,970	10/1995	GUTKIN			

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